



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Tomowaki TAKAHASHI

Group Art Unit: 2851

Application No.: 10/685,383

Examiner: D. Rutledge

Filed: October 16, 2003

Docket No.: 116949

For: PROJECTION OPTICAL SYSTEM AND EXPOSURE APPARATUS EQUIPPED
WITH THE PROJECTION OPTICAL SYSTEM

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the July 27, 2004 Office Action, the shortened statutory period for reply
being extended by the attached Petition for Extension of Time, please consider the following:

Amendments to the Specification;

Amendments to the Claims as reflected in the listing of claims; and

Remarks.